



THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: **IZUMI, Katsutoshi, et al.**

Group Art Unit: **2815**

Serial Number: **10/699,832**

Examiner: **JEROME JACKSON JR.**

Filed: **November 4, 2003**

P.T.O. Confirmation No.: 5574

For. **MONOCRYSTALLINE GALLIUM NITRIDE LOCALIZED SUBSTRATE
AND MANUFACTURING METHOD THEREOF**

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

February 5, 2007

Sir:

In compliance with 37 CFR 1.56, Applicant calls to the attention of the Patent and
Trademark Office the references listed on the attached PTO-1449.

A copy of each of the references is enclosed herewith.

In the event there are any fees due in connection with the filing of this paper, please
charge Deposit Account No. 01-2340.

Respectfully submitted,

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PATENT TRADEMARK OFFICE

Enclosures: PTO-1449; References (2)



INFORMATION DISCLOSURE STATEMENT PTO-1449	Atty. Docket No. 031258	Serial No. 10/699,832
	Applicant(s): IZUMI, Katsutoshi, et al.	
	Filing Date: November 4, 2003	Group Art Unit: 2815

U.S. PATENT DOCUMENTS

Examiner Initial	Document No.	Name	Date	Class	Subclass	Filing Date (If appropriate)
_____	AA					
_____	AB					
_____	AC					
_____	AD					

FOREIGN PATENT DOCUMENTS

Document No.	Date	Country	Translation (Yes or No)	
_____	AE	JP 2001-044124 A	Japan	Yes
_____	AF			
_____	AG			
_____	AH			
_____	AI			

OTHER DOCUMENTS

_____	AJ	Chinese Office action dated December 8, 2006, with translation.
_____	AK	
Examiner		Date Considered